

Handbook Of Ion Implantation Technology

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Patents Publication number More technical discussion can be found in Handbook of Ion Implantation Technology, J. C. Ziegler, ed.; Elsevier Science Publishers B. V

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Ion plating is a physical vapor "Handbook of Plasma Immersion Ion Implantation and Deposition" (2000) Wiley Donald M. "The Foundations of Vacuum Coating

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'> junction through the control of ion implantation-induced defects in silicon substrate - Handbook of Ion Implantation Technology,

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Semiconductor Science and Technology Volume 20 Ziegler J F 1992 Handbook of Ion Implantation Technology Investigation of ion implantation induced intermixing

Broad ion beam technology applied to thin film etching allows a range of 2461-2732. 4. Handbook of Ion Implantation Technology, edited by J. F. Ziegler

Ion implantation is the primary technology which is used in the semiconductor industry to introduce impurities into semiconductors to form devices and VLSI circuits.

Stephens, K.G., in Handbook of Ion Implantation Technology edited by J.F. Ziegler, p. 455 - Elsevier 1992

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1 Interactions of ion beams with polymers: the physical picture. Alexey Handbook of ion implantation technology, Elsevier (2003) V.B. Odzhaev, I.P

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P. 34: I. G. Brown, "The Physics and Technology of Ion Sources,". New York: Wiley, 1989. B. Wolf, Handbook of Ion Sources. Boca Raton: CRC Press, 1995.

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